



PATENT

Case Docket No. ASMEEX.186DV1

Date: July 8, 2002

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In re application of: Raaijmakers et al.
Appl. No. : 09/764711
Filed : January 18, 2001
For : METHOD OF
DEPOSITING SILICON
*WITH HIGH STEP
COVERAGE
Examiner : Angel Roman
Art Unit : 2812

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July 8, 2002

(Date)

Adeel S. Akhtar
Adeel S. Akhtar, Reg. No. 41,394

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Sir:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	5	20	= 0 ×	\$18	= \$0
Independent Claims	1	3	= 0 ×	\$84	= \$0
If application has been amended to contain multiple dependent claim(s), then add				\$280	= \$0
Time Extension Fee					\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

(X) Response to Final Office Action;

(X) Return prepaid postcard;

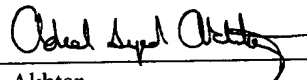
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- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.



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